



Docket No.: Z&PINFP08190

#17/IDS  
3/9/84

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 09/904,360 Confirmation No.: 1413  
Inventor : Giuseppe Curello et al.  
Filed : July 12, 2001  
Title : Process for Producing a Doped Semiconductor Substrate  
TC/A.U. : 2825  
Examiner : Igwe U. Anya  
Customer No.: 24131

Hon. Commissioner for Patents  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. 1.97(b)(4)

Sir:

In accordance with 37 C.F.R. 1.97(b)(4), a copy of the following U.S. patent is submitted herewith:

U.S. Patent No. 5,296,388 (Kameyama et al.), dated March 22, 1994.

Respectfully submitted,

For Applicants

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Date: February 5, 2004

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